

Notice of References Cited	Application/Control No. 10/721,441	Applicant(s)/Patent Under Reexamination MYERS ET AL.	
	Examiner Savitri Mulpuri	Art Unit 2812	Page 1 of 1

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	C	US-6,582,987	06-2003	Jun et al.	438/49
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NON-PATENT DOCUMENTS

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	U	Joo et al, "Fabrication of Monolithic Microchannels for IC Chip Cooling" 1995 IEEE pp 362-367
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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